

AF/JPW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of: Kye Nam Lee  
et al.

Confirmation No.: 7874

Serial No.: 10/608,081

Art Unit: 1765

Filed: June 30, 2003

Examiner: Lan VINH

For: METHOD FOR MANUFACTURING MAGNETIC RANDOM ACCESS MEMORY

**REPLY UNDER 37 C.F.R. § 1.116**

Commissioner for Patents

**Attn: Mail Stop AF**

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action, mailed on July 26, 2005 in the above-captioned patent application, consideration of the following remarks are respectfully requested to place the application in condition for allowance. The Commissioner is authorized to credit any overpayment or charge any deficiency to Deposit Account No. 08-1641.

**Remarks/Arguments** begin on page 2 of this document.